756-28129-01

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re New Patent Application of		)	
Hajime KIMURa		)	•
Japanese Priority No.:	2000-156111	) Attn:	Applications
Japanese Priority Date:	May 26, 2000	)	Branch
For: MOS SENSOR AND DRIVE METHOD		) Date:	May 25, 2001
THEREOF		)	

## INFORMATION DISCLOSURE STATEMENT

Commissioner for Patents

Washington, D.C. 20231

Sir:

In accordance with the provisions of 37 C.F.R. 1.56 and 37 C.F.R. 1.97-1.99, it is requested that the reference(s) listed on the attached Form PTO-1449 be made of record in the above-identified application.

At least some of the references listed on the attached Form PTO-1449 are discussed in the specification of the subject application.

Copies of the references are submitted herewith in accordance with 37 C.F.R. 1.98(a).

Respectfully submitted,

Jeffrey L. Costellia Registration No. 35,483

Nixon Peabody LLP

8180 Greensboro Drive, Suite 800

McLean, Virginia 22102

(703) 790-9110

JLC/sas

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## **Information Disclosure Statement**

Please submit to the U.S. Patent office an Information Disclosure Statement disclosing the following.

